

Search Notes

Application/Control No.

10/660,306

Examiner

Christopher K. Agrawal

Applicant(s)/Patent under
Reexamination

LIU, HEBEN

Art Unit

3726

SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|-----------|----------|
| 29 | 890.032 | 5/11/2006 | CKA |
| | 890.045 | 5/11/2006 | CKA |
| | 890.046 | 5/11/2006 | CKA |
| | 890.05 | 5/11/2006 | CKA |
| | 726 | 5/11/2006 | CKA |
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INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
|--------|----------|-----------|----------|
| see | attached | 5/11/2006 | CKA |
| search | history | 5/11/2006 | CKA |
| | | | |
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**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
|---|-----------|------|
| see attached EAST workspace for search history | 5/11/2006 | CKA |
| consulted Examiner Compton regarding field of search | 5/11/2006 | CKA |
| updated search and consulted 10/318591 | 5/11/2006 | CKA |
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